

L Number	Hits	Search Text	DB	Time stamp
1	47205	((force load stres strain weight) near3 (test\$5 detect\$5 sens\$5 estimat\$5 evalut\$5 determin\$5 measur\$5 transducer cell meter gauge monitor\$5 ))).clm.	USPAT; EPO; JPO	2004/11/02 12:27
2	287	((((force load stres strain weight) near3 (test\$5 detect\$5 sens\$5 estimat\$5 evalut\$5 determin\$5 measur\$5 transducer cell meter gauge monitor\$5 ))).clm.) and ((upper lower top bottom) near3 (electrode conduct\$5)).clm.	USPAT; EPO; JPO	2004/11/02 12:27
3	77	(((((force load stres strain weight) near3 (test\$5 detect\$5 sens\$5 estimat\$5 evalut\$5 determin\$5 measur\$5 transducer cell meter gauge monitor\$5 ))).clm.) and ((upper lower top bottom) near3 (electrode conduct\$5)).clm.) and substrate.clm.	USPAT; EPO; JPO	2004/11/02 12:27
4	19	(((((force load stres strain weight) near3 (test\$5 detect\$5 sens\$5 estimat\$5 evalut\$5 determin\$5 measur\$5 transducer cell meter gauge monitor\$5 ))).clm.) and ((upper lower top bottom) near3 (electrode conduct\$5)).clm.) and substrate.clm.) and ("n-type" "p-type")	USPAT; EPO; JPO	2004/11/02 12:31
5	21	(((((force load stres strain weight) near3 (test\$5 detect\$5 sens\$5 estimat\$5 evalut\$5 determin\$5 measur\$5 transducer cell meter gauge monitor\$5 ))).clm.) and ((upper lower top bottom) near3 (electrode conduct\$5)).clm.) and substrate.clm.) and capacit\$7.clm.	USPAT; EPO; JPO	2004/11/02 12:32
6	13	(((((force load stres strain weight) near3 (test\$5 detect\$5 sens\$5 estimat\$5 evalut\$5 determin\$5 measur\$5 transducer cell meter gauge monitor\$5 ))).clm.) and ((upper lower top bottom) near3 (electrode conduct\$5)).clm.) and substrate.clm.) and ("n-type" "p-type")) and capacit\$7	USPAT; EPO; JPO	2004/11/02 12:34
7	13	((((((force load stres strain weight) near3 (test\$5 detect\$5 sens\$5 estimat\$5 evalut\$5 determin\$5 measur\$5 transducer cell meter gauge monitor\$5 ))).clm.) and ((upper lower top bottom) near3 (electrode conduct\$5)).clm.) and substrate.clm.) and ("n-type" "p-type")) and capacit\$7) and (semiconductor transistor)	USPAT; EPO; JPO	2004/11/02 12:35
8	14	((((((force load stres strain weight) near3 (test\$5 detect\$5 sens\$5 estimat\$5 evalut\$5 determin\$5 measur\$5 transducer cell meter gauge monitor\$5 ))).clm.) and ((upper lower top bottom) near3 (electrode conduct\$5)).clm.) and substrate.clm.) and capacit\$7.clm.) and (semiconductor transistor)	USPAT; EPO; JPO	2004/11/02 12:35

Max Noori  
11/2/04